## IN THE CLAIMS:

Claims 1-20 have been amended herein. All of the pending claims 1 through 20 are presented below. This listing of claims will replace all prior versions and listings in the application. Please enter these claims as amended.

- 1. (Currently Amended) In a wire bonding apparatus for bonding a wire to a bond pad located on a-semiconductor semiconductor chip and a lead finger of a lead frame of a plurality of lead frames being supplied to said wird the wire bonding apparatus in a strip form, said the apparatus comprising:
- a wire bonding apparatus having a portion thereof for dispensing-of said the wire to be bonded to said the bond pad and-said the lead finger and bonding-said the wire to-said the bond pad or-said the lead finger;
- an independent clamp for engaging-another a portion of said the lead finger before said bonding of said the wire thereto, said the independent clamp being independently movable in relation to movement of another portion of said the wire bonding apparatus and said the lead finger of said the lead frame for engaging a portion of said the lead finger; and a conventional fixed clamp for engaging another portion of said the lead finger adjacent said the independent clamp.
- 2. (Currently Amended) The apparatus of claim 1, wherein-said the independent clamp is located between-said the wire bonding apparatus and-said the conventional fixed clamp for engaging said the portion of said the lead finger during said bonding of said the wire thereto.
- 3. (Currently Amended) The apparatus of claim 1, wherein-said the independent clamp includes having an ability to move independently in an x-axis direction, y-axis direction and z-axis direction.

- 4. (Currently Amended) The apparatus of claim 1, wherein-said the independent clamp is movable independently in any direction of a movement of said the wire bonding apparatus.
- 5. (Currently Amended) The apparatus of claim 1, wherein-said the apparatus further comprises:
  heating apparatus located beneath-said the semiconductor chip.
- 6. (Currently Amended) The apparatus of claim 1, wherein-said the apparatus further comprises:
  heating apparatus located beneath-said the lead finger.
- 7. (Currently Amended) The apparatus of claim 6, wherein-said the semiconductor chip is heated before-said the wire is bonded thereto.
- 8. (Currently Amended) The apparatus of claim 1, wherein-said the independent clamp is resiliently mounted.
- 9. (Currently Amended) The apparatus of claim 8, wherein said the independent clamp is resiliently mounted through use of a spring engaging a portion of said the independent clamp.
- 10. (Currently Amended) The apparatus of claim 1, wherein-said the independent clamp has an end portion thereof which is insulated.
- 11. (Currently Amended) The apparatus of claim 1, wherein-said the independent clamp has an end portion thereof which is semicircular in shape.

- 12. (Currently Amended) The apparatus of claim 1, wherein-said the independent clamp has an end portion thereof which is arcuate in shape.
- 13. (Currently Amended) The apparatus of claim 1, wherein-said the independent clamp has an end portion thereof which is articulated for movement.
- 14. (Currently Amended) The apparatus of claim 1, wherein-said the independent clamp is located between-said the wire bonding apparatus and said the conventional fixed clamp engaging-said the portion of-said the lead finger during-said bonding of-said the wire thereto.
- 15. (Currently Amended) A wire bonding apparatus for bonding a wire to a bond pad located on a semiconductor chip and a lead finger of a lead frame of a plurality of lead frames supplied to-said the wire bonding apparatus in a strip form,-said the apparatus comprising: wire bonding apparatus having a portion thereof for dispensing of said the wire to be bonded to said the bond pad and-said the lead finger and bonding-said the wire to-said the bond pad or-said the lead finger;

a conventional fixed clamp for engaging a portion of said the lead finger; and an independent clamp for engaging another portion of said the lead finger before said bonding of said the wire thereto, said the independent clamp having an ability to move as desired in an x-axis-direction direction, a y-axis direction, and a z-axis direction concurrently regarding a portion of said the lead finger and being independently movable in relation to movement of another portion of said the wire bonding apparatus.

16. (Currently Amended) The apparatus of claim 15, wherein-said the independent clamp is movable independent of a movement of-said the wire bonding apparatus.

17. (Currently Amended) The apparatus of claim 15, wherein said the apparatus further comprises:

heating apparatus located beneath-said the semiconductor chip.

18. (Currently Amended) The apparatus of claim 17, wherein-said the apparatus further comprises:

heating apparatus located beneath-said the lead finger.

- 19. (Currently Amended) The apparatus of claim 17, wherein-said the semiconductor chip is heated before-said the wire is bonded thereto.
- 20. (Currently Amended) The apparatus of claim 15, wherein-said the independent clamp is resiliently mounted.